

Supporting Information:

CsCl Seed Layer Engineering for Buried-Interface Modification Enabling >20% Efficiency in Single-Source Vapor-Deposited Perovskite Solar Cells

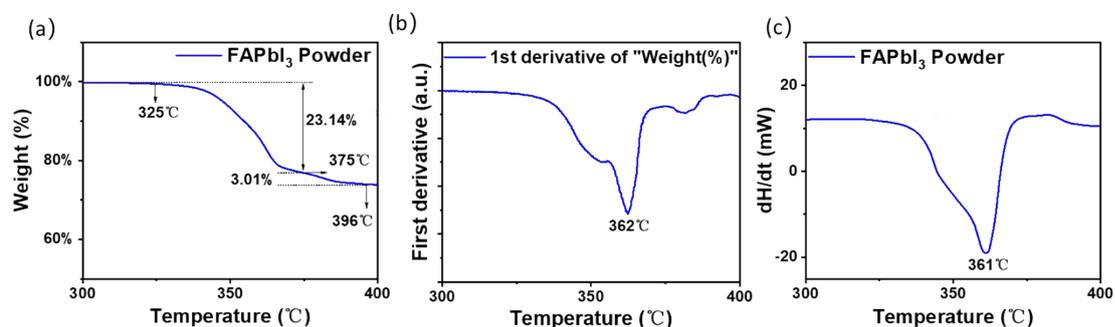


Fig. S1: (a) TGA curve, (b) 1st derivative of TGA curve and (c) DSC curve of FAPbI₃ powder.

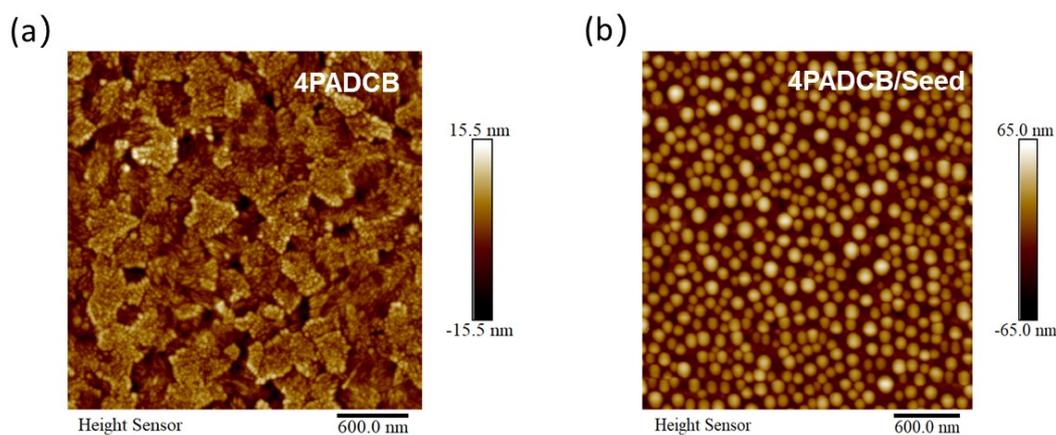


Fig. S2: The AFM images of (d) 4PADCBC film and (e) 4PADCBC/Seed film.

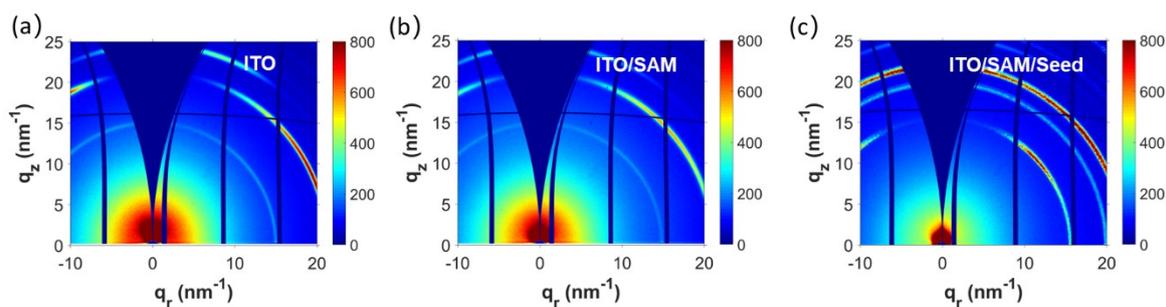


Fig S3: Two-dimensional GIWAXS (2D-GIWAXS) patterns of (a) ITO, (b) ITO/4PADCBC (c) ITO/4PADCBC/Seed.

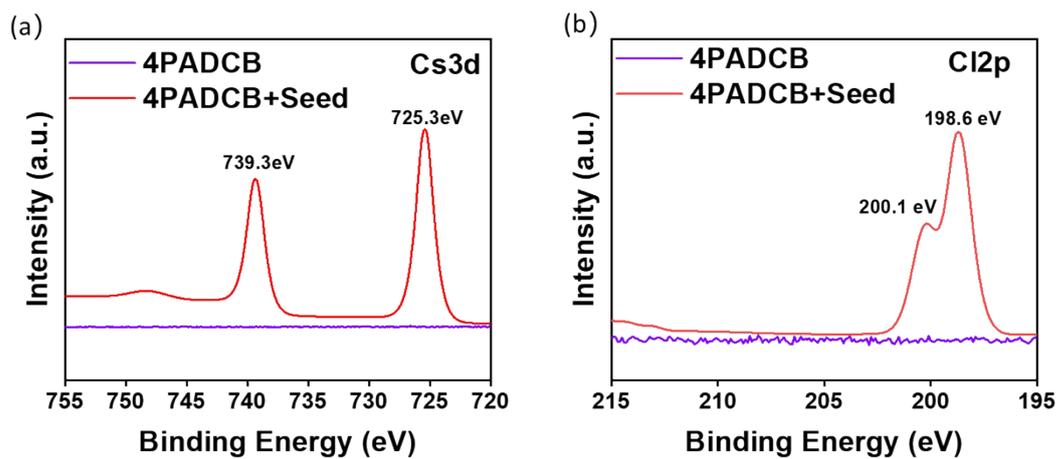


Fig. S4: The XPS patterns of (a) Cs3d and (b) Cl2p of 4PADCB and 4PADCB+Seed.

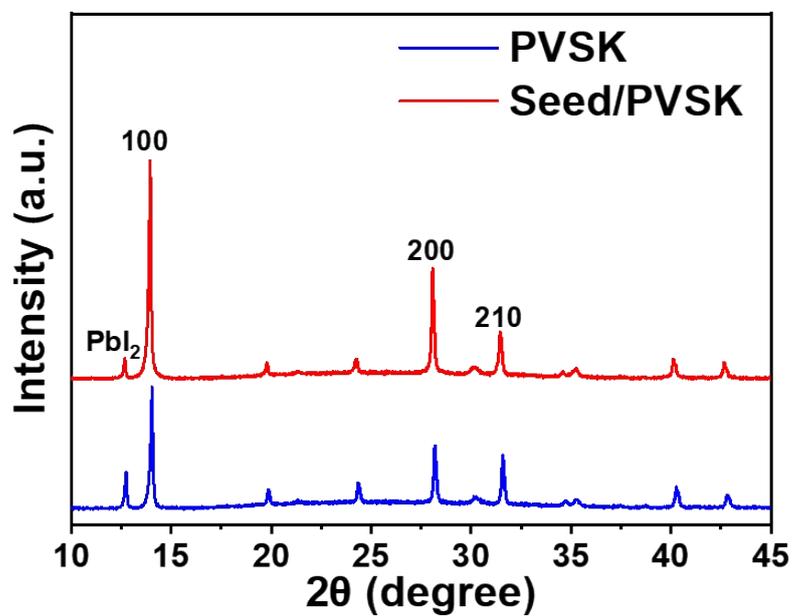


Fig. S5 : The XRD patterns of PVS and Seed/PVS films.

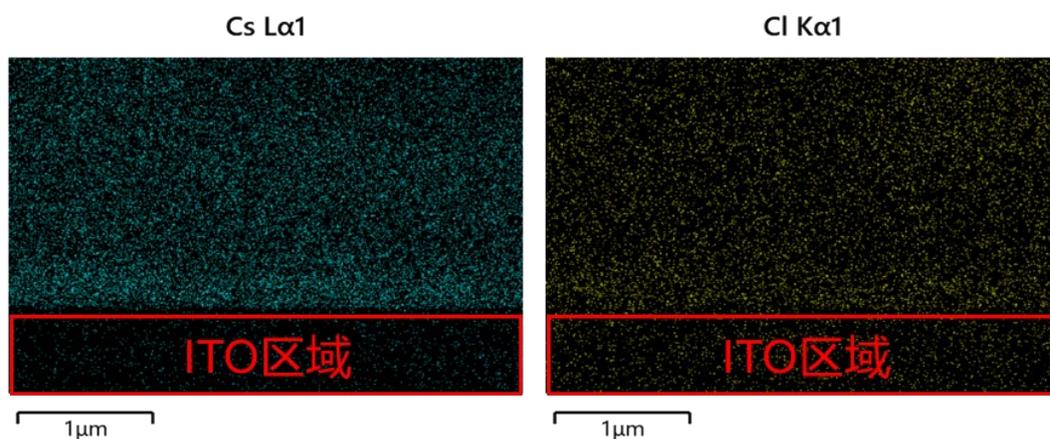


Fig. S6: EDS data of the ITO/4PADCB/Seed/perovskite structure, including Cs, Cl.

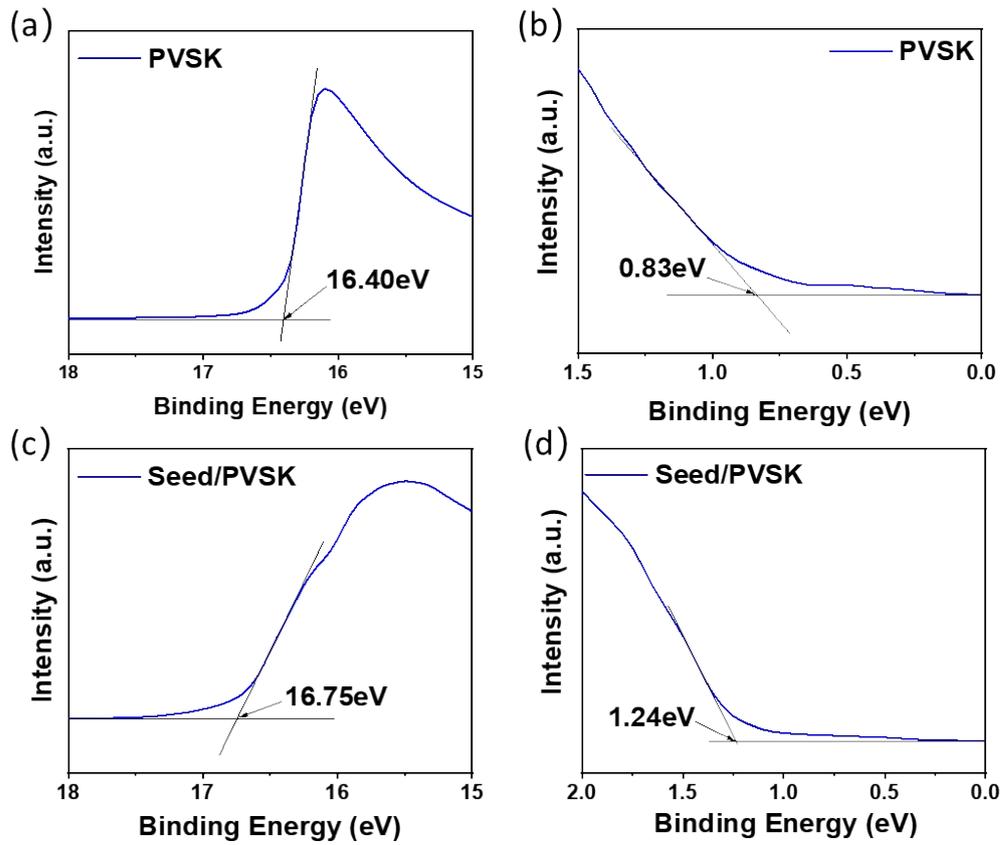


Fig. S7: UPS spectra of PVSK sample in the (a) onset and (b) cutoff energy region. UPS spectra of Seed/PVSK samples in the (c) onset and (d) cutoff energy region.

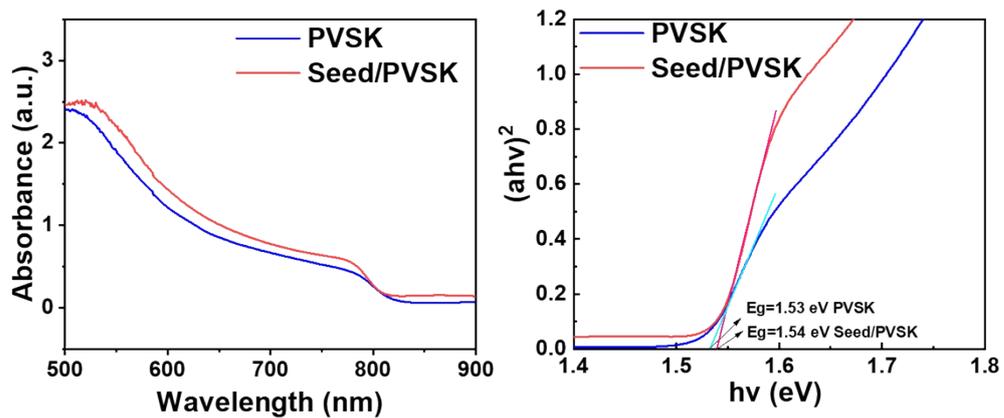


Fig. S8: The Absorbance (a) and UPS spectra (b) of perovskite films on PVSK and Seed/PVSK.

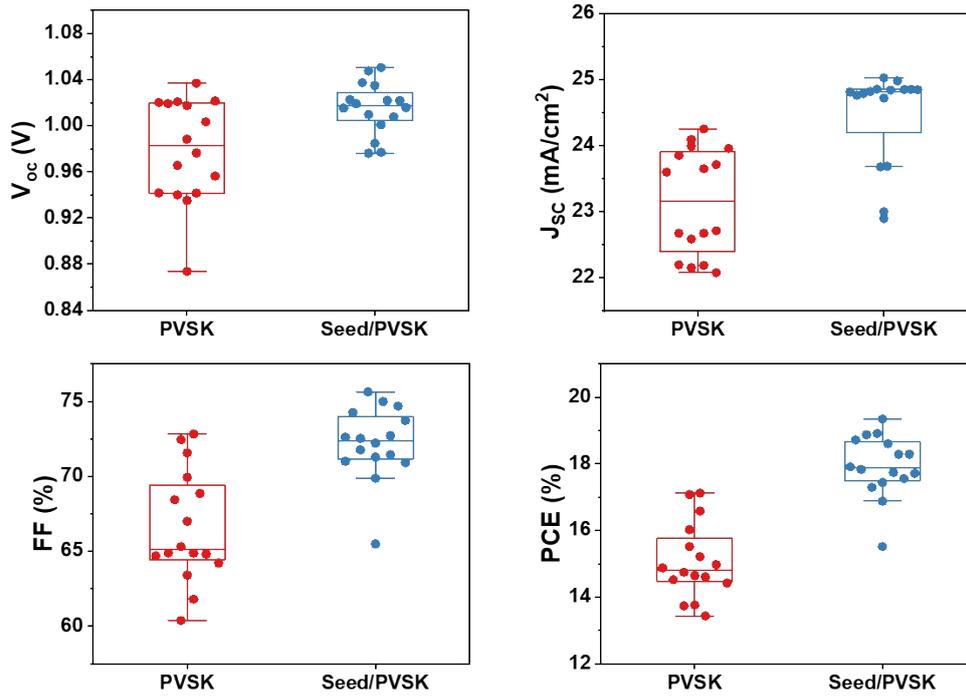


Fig. S9: Statistical photovoltaic parameters of (a) V_{oc} , (b) J_{sc} , (c) FF, (d) PCE of PSCs using PVS and Seed/PVS.

Table S1. Fitted TRPL parameters of PVS with and without CsCl seed layer.

	$\tau_{ave}(ns)$	A1	$\tau_1(ns)$	A2	$\tau_2(ns)$
PVS	54.80	0.77	3.91	0.14	70.07
Seed/PVS	177.33	0.46	25.7	0.48	196.2

Table S2. PV parameters extracted from the most efficient PSCs under different structures.

Structure	$V_{oc}(V)$	$J_{sc}(mA/cm^2)$	FF(%)	PCE(%)
ITO/2PACz/FAPbI ₃ /C60/SnO _x /Ag	1.001	20.546	62.003	12.747
ITO/Meo-2PACz/FAPbI ₃ /C60/SnO _x /Ag	0.991	23.550	72.203	16.851
ITO/4PADCb/FAPbI ₃ /C60/SnO _x /Ag	1.018	23.709	72.268	17.458
ITO/4PADCb:Meo-2PACz=1:1/FAPbI ₃ /C60/SnO _x /Ag	0.947	24.318	68.858	15.862
ITO/NiO _x /Me-4PACz/FAPbI ₃ /C60/SnO _x /Ag	1.083	20.158	63.572	13.879
ITO/4PADCb/5nmCsCl/FAPbI ₃ /C60/SnO _x /Ag	1.008	24.877	73.950	18.536
ITO/4PADCb/15nmCsCl/FAPbI ₃ /C60/SnO _x /Ag	1.042	25.097	77.435	20.258

ITO/4PADCB/25nmCsCl/FAPbI ₃ /C60/SnO _x /Ag	1.012	25.450	73.821	19.009
ITO/4PADCB/35nmCsCl/FAPbI ₃ /C60/SnO _x /Ag	0.985	24.841	72.529	17.741

Table S3. The report presents the device efficiency and publication dates corresponding to the single-source vapor deposition methods for solar cell devices with different compositions.

Ref.	Method	Device stack (Composition)	PCE (%)	Year
1	Thermal evaporation	ITO/PEDOT:PSS/ MAPbI ₃ /PCBM/Ag	10.9	2016
2		ITO/PEDOT:PSS/MAPbI ₃ /PC ₆₁ BM/Ag	7.7	2018
3		ITO/PEDOT:PSS/ MAPbI ₃ /PCBM/Ag	9.9	2019
4		FTO/TiO ₂ /Cs ₂ AgBiBr ₆ /Spiro-OMeTAD/Ag	0.7	2019
5		FTO/PCBM/CsSn _{0.5} Ge _{0.5} I ₃ /Spiro-OMeTAD/Au	7.1	2019
6		FTO/c-TiO ₂ /CsPbBr ₃ /Spiro-OMeTAD/Au	8.7	2020
7		FTO/TiO ₂ /CsSn _{1-y} Pb _y Br ₃ /carbon	9	2021
8		FTO/TiO ₂ /CsPbBr ₃ /Spiro-OMeTAD/Ag	1.37	2021
9		FTO/TiO ₂ /Cs ₂ AgBiBr ₆ /SpiroOMeTAD/Ag	1.38	2022
10		ITO/PEDOT:PSS/MASnI ₃ /C ₆₀ /Au	1.7	2022
11		FTO/TiO ₂ /CsPbBr ₃ /Carbon	7.5	2023
12		ITO/MeO-2PACz/Cs _x PbI _y Br _z /C ₆₀ /BCP/Ag	15.0	2023
13		FTO/TiO ₂ /CsPbBr ₃ QDs/CsPbBr ₃ /Spiro-OMeTAD/Au	7.0	2023
14		ITO/TiO ₂ :SnO ₂ NRs/(BA) ₂ (MA) ₃ Pb ₄ I ₁₃ /Spiro-OMeTAD/Au	13.6	2024
This work		ITO/4PADCB/PVSK/C ₆₀ /SnO ₂ /Ag	17.8,	2025

		ITO/4PADCB/CsCl/PVSK/C ₆₀ /SnO ₂ /Ag	20. 26	
15	Flash evaporation	ITO/PEDOT:PSS/PolyTPD/MAPbI ₃ /PCBM/Ba/Ag	12. 2	20 15
16		FTO/PCBM/MAPbI ₃ /Spiro-OMeTAD/Au	10. 0	20 16
17		FTO/TiO ₂ /PCBM/MAPbI ₃ /Spiro-OMeTAD/Au	16. 8	20 18
18		FTO/PCBM/MAPbI ₃ /Spiro-OMeTAD/Au	12. 2	20 19
19		FTO/PCBM/FAPbI ₃ /Spiro-OMeTAD/Au	12. 5	20 19
20		ITO/SnO ₂ /CsPb(I _{0.67} Br _{0.33}) ₃ /Spiro-MeOTAD/Au	15. 0	20 24
21	PLD	ITO/ZnO/MAPb(I _γ Cl _{1-γ}) ₃ /Spiro-OMeTAD/Au	7.7	20 15
22		FTO/TiO ₂ /MAPbI ₃ /Spiro-OMeTAD/Au	10. 9	20 17
23		FTO/c-TiO ₂ /m-TiO ₂ /CsPbBr ₃ /Spiro-OMeTAD/Ag	6.3	20 19
24		ITO/SnO ₂ /C ₆₀ /MAPbI ₃ /TaTm/MoO ₃ /Au	6.7	20 21
25		ITO/SnO ₂ (ALD)/C ₆₀ /MA _x FA _{1-x} PbI ₃ /TaTm/MoO ₃ /Au ITO/SnO ₂ /PCBM/MA _x FA _{1-x} PbI ₃ /Spiro-OMeTAD/Au	9.9	20 23
26		ITO/2PACz/MA _{1-x} FA _x PbI ₃ /C ₆₀ /BCP/Ag	19. 7	20 24
27	Electron beam evaporation	FTO/c-TiO ₂ /CsPbBr ₃ /carbon	7.8	20 22
28	sputtering	MAPbI ₃ , MA _x PbI ₃ Cl _y	4.7 15. 2	20 21

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